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# PATENT

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J1044 U.S. PTO

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09/883437  
06/18/01

Express Mail Label No.: EL822653156US

Case Docket No.: 2001P10755US  
(8055-31)

Date: 6/18/01

ASSISTANT COMMISSIONER FOR PATENTS  
Washington, D.C. 20231  
Box PATENT APPLICATION

Sir:  
Transmitted herewith for filing is the patent application of:

Inventor(s): Uwe Paul Schroeder, Tobias Mono

For: HIGH CONTRAST LITHOGRAPHY ALIGNMENT MARKS FOR SEMICONDUCTOR  
MANUFACTURING

This application includes:

23 pages: specification, claims, abstract  
16 sheets of drawings,      formal x Informal  
     photographs

Also enclosed is:

     An Assignment of the invention to Assignee(s):  
      
     A certified copy of      application  
     Declaration and Power of Attorney  
     Information Disclosure Statement pursuant to 37 CFR 1.56  
     Form PTO-1449  
     Form PTO-1595  
X Post Card

The filing fee has been calculated as shown below:

FOR:	(Col. 1) NO. FILED	(Col. 2) NO. EXTRA RATE	OTHER THAN A SMALL ENTITY FEE
BASIC FEE	XXXXXXXX	XXXXXXXX	XXXXX \$710
TOTAL CLAIMS	<u>18</u> - 20 =	<u>0</u>	X \$18 = \$0
INDEP CLAIMS	<u>3</u> - 3 =	<u>0</u>	X \$80 = \$0
* MULTIPLE DEPENDENT CLAIM PRESENTED			+ 270 = \$0
ASSIGNMENT(S)	<u>0</u>		X \$40 = \$
			TOTAL \$710.00

Infineon Technologies North America Corp.  
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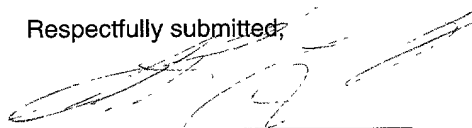
09883437 061801

- 2 -

X A fee of \$ \_\_\_\_\_ to cover recordation of the Assignment(s).  
X Please charge my Deposit Account No. 19-2179 in the amount of \$710.00. A duplicate copy of this sheet is enclosed.  
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Date: 6/15/11

Respectfully submitted,



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PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Schroeder et al.

Docket: 2001 P 10755 US (8055-31)

Filed: June 18, 2001

For: HIGH CONTRAST LITHOGRAPHY ALIGNMENT MARKS FOR  
SEMICONDUCTOR MANUFACTURING

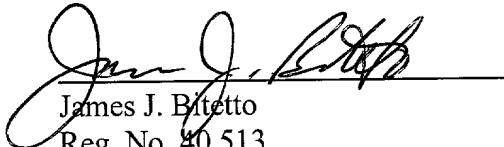
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Assistant Commissioner for Patents  
Washington, D.C. 20231

CERTIFICATION UNDER 37 C.F.R. § 1.10

I hereby certify that the documents enclosed herein are being deposited with the United States Postal Service on this date June 18, 2001 in an envelope as "Express Mail Post Office to Addressee" Mail Label Number EL822653156US addressed to: Assistant Commissioner for Patents, BOX PATENT APPLICATION, Washington, D.C. 20231.

Dated: 6/18/01

  
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